Search Notes		

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/734,674	CHOI ET AL	
Examiner	Art Unit	
RICARDO L. OSORIO	2629	

SEARCHED				
Class	Subclass	Date	Examiner	
345	589,690 63,77 89,102 204	4/16/07	RLO	
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INTERFERENCE SEARCHED				
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